

03500.015442.



PATENT APPLICATION

2811#4
S.I.
04-24-02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
: Examiner: N.Y.A.
TAKAMASA ISHII ET AL.)
: Group Art Unit: 2811
Application No.: 09/879,214)
: Filed: June 13, 2001)
: For: SEMICONDUCTOR DEVICE,)
: RADIATION DETECTION)
: DEVICE, AND RADIATION)
: DETECTION SYSTEM)
: February 21, 2002

RECEIVED

APR 18 2002

Commissioner for Patents
Washington, D.C. 20231

Technology Center 2600

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the following U.S. applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
08/964,797	11/05/1997	2823
09/845,284	05/01/2001	2814

A copy of each cited application is enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

RECEIVED
FEB 25 2002
TC 2800 MAIL ROOM

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No. 28,296

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

NY_MAIN 240313v1